

INFORMATION DISCLOSURE CITATION
(Use several sheets if necessary)

Docket Number (Optional)

Application Number

Applicant(s)
Heinrich Meyer et al

532 rec'd PCT/PTC 18 OCT 2000

Filing Date

Herewith

Group Art/Unit

1763

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
AWO	AA	3,294,059	12/27/66	Barnes et al	118	049.5	
AWO	AB	4,717,587	1/5/88	Suhr et al	427	039	
AWO	AC	4,990,363	2/5/91	Suhr et al	427	040	

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
AWO	AL	35 10 982 A1	9/25/86	Germany				
	AM	35 12 196 A1	10/16/86	Germany				
	AN	37 44 062 A1	7/13/89	Germany				
	AO	38 06 587 A1	9/7/89	Germany				
AWO	AP	44 38 791 A1	4/25/96	Germany				

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

AWO	AR	"Thin Palladium Films Prepared by Metal-Organic Plasma-Enhanced Chemical Vapor Deposition", Thin Solid Films, Band 157 (1988), p. 81-86.

EXAMINER

DATE CONSIDERED

6-19-03

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.